## **ABSTRACT**

A method of manufacturing single-crystal semiconductor wafers is characterized in that a plurality of single-crystal semiconductor wafers of a relatively small diameter (2a-2d) desired by users are cut out from a single-crystal semiconductor wafer of a relatively large diameter (1a-1d). Therefore, there can also be obtained a secondary effect that even if the large-scale single-crystal semiconductor wafer has defective parts, the small-scale wafers cut out from the non-defective parts can be shipped to the market.

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